

# Diana Mata-Hernandez

## List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/6537848/publications.pdf>

Version: 2024-02-01

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papers

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citations

3311381

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#	ARTICLE	IF	CITATIONS
1	Resonant MEMS Pressure Sensor in 180 nm CMOS Technology Obtained by BEOL Isotropic Etching. Sensors, 2020, 20, 6037.	3.8	7
2	Hardware-Software Co-Design for Efficient and Scalable Real-Time Emulation of SNNs on the Edge. , 2021, , .		3